

## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 2823

**PATENT** 

Customer No. 22,852 Attorney Docket No. 04329.3210

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takeshi Shibata et al.

Application No.: 10/743,522

Filed: December 23, 2003

For: STENCIL MASK WITH CHARGE-UP PREVENTION AND METHOD OF MANUFACTURING THE SAME

O Group Art Unit: 2823

Examiner: Nguyen, Khiem D.

Confirmation No.: 7673

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed May 14, 2007, the period for response to which extends through August 14, 2007, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment section of this paper.

Af Jan